



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 9850
Shinji KAJITA et al. : Attorney Docket No. 2004_0120A
Serial No. 10/765,182 : Group Art Unit 1746
Filed January 28, 2004 : Examiner Mark J. Heckert

APPARATUS FOR AND METHOD OF
PROCESSING SUBSTRATE

O.K. Enter
TO EN 108
AEP per KLE
1/22/08

: Mail Stop: AF

AMENDMENT

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action of September 26, 2007, please amend the above-referenced U.S. patent application as follows:

**RESPONSE UNDER 37.CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1746**

*Do Not
File
8*